

103
PATENT
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SEP. 29 2003

#25WB
10/8/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroshi IKEDA et al

SERIAL NO: 09/463,961

GROUP ART UNIT: 1754

FILED: May 25, 2000

EXAMINER: Timothy VANOV

FOR: PROCESS AND APPARATUS FOR TREATING
SEMICONDUCTOR PRODUCTION EXHAUST GASES

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. §1.136

RECEIVED
OCT 03 2003
TC 1700

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **two** month extension of time be granted to October 5, 2003 for:

- filing a response to the Official Action dated:
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal.
- filing an Appeal Brief. A Notice of Appeal was filed on:
- Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$410.00 is enclosed herewith by credit card payment form and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
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RE FC:1252

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